

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: : **Mami MIYASAKA**
Filed : **Concurrently herewith**
For : **ELECTRON BEAM EXPOSURE MASK,...**
Serial No. : **Concurrently herewith**

September 8, 2003

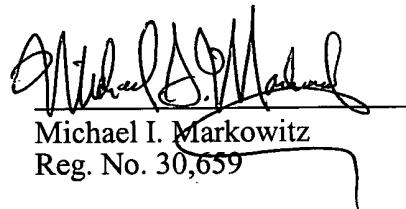
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRIORITY CLAIM AND
SUBMISSION OF PRIORITY DOCUMENT

SIR:

Applicant hereby claims priority under 35 USC 119 from **Japanese** patent application number **11-232358** filed **August 19, 1999**, a copy of which was made of record in parent application number **09/641,125**.

Respectfully submitted,



Michael I. Markowitz
Reg. No. 30,659

Katten Muchin Zavis Rosenman
575 Madison Avenue
New York, NY 10022-2585
(212) 940-8800
Docket No.: NECF 17.638A